

August 19, 2003

**MAIL STOP PATENT APPLICATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Re: Application of Kesahiro KOIKE and Junji MIYAGAKI  
METHOD OF PRODUCING A GLASS SUBSTRATE FOR A MASK  
BLANK, METHOD OF PRODUCING A MASK BLANK, METHOD OF  
PRODUCING A TRANSFER MASK, METHOD OF PRODUCING A  
SEMICONDUCTOR DEVICE, GLASS SUBSTRATE FOR A MASK  
BLANK, MASK BLANK, AND TRANSFER MASK  
**Assignee: HOYA CORPORATION**  
Our Ref. Q77049

Dear Sir:

Attached hereto is the application identified above comprising thirty-six (36) sheets of the specification, including the claims and abstract, one (1) sheet of drawings, executed Assignment and PTO 1595 form, and executed Declaration and Power of Attorney. Also enclosed is an Information Disclosure Statement and PTO/SB/08 A & B (modified).

The Government filing fee is calculated as follows:

Total claims	21	-	20	=	1	x	\$18.00	=	\$18.00
Independent claims	6	-	3	=	3	x	\$84.00	=	\$252.00
Base Fee									\$750.00
Multiple Dependent Claim Fee									\$280.00

<b>TOTAL FILING FEE</b>	\$1300.00
Recordation of Assignment	\$40.00
<b>TOTAL FEE</b>	<b>\$1340.00</b>

Checks for the statutory filing fee of \$1300.00 and Assignment recordation fee of \$40.00 are attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this transmittal letter is attached.



**MAIL STOP PATENT APPLICATION**

Attorney Docket No. **Q77049**

Priority is claimed from:

Country

Application No

Filing Date

**Japan**

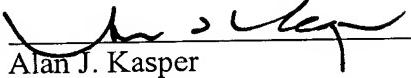
**2002-238576**

**August 19, 2002**

The priority document will be filed at a later date.

Respectfully submitted,  
SUGHRUE MION, PLLC

Attorneys for Applicant

By:   
Alan J. Kasper  
Registration No. 25,426

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER